



Attorney's Docket No.: 042390.P4222D2

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Patent  
Technology Center 2800  
OCT 15 2002

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Robert S. Chau, et al.

Application No:09/654,315

Filed: September 1, 2000

For: DEVICE STRUCTURE AND METHOD  
FOR REDUCING SILICIDE  
ENCROACHMENT

Examiner: Tran, T.F.

Art Unit: 2811

Commissioner for Patents  
Washington, D.C. 20231

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V.A. Edwards  
10/28/02  
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AMENDMENT AND RESPONSE

Dear Sir:

This is in response to the Office Action mailed April 1, 2002, Applicant respectfully requests the Examiner to enter the following amendments and consider the following remarks.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Commissioner of Patents, Washington, D.C. 20231

on October 1, 2002  
Date of Deposit

Teresa Edwards

Name of Person Mailing Correspondence

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Signature

October 1, 2002

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